Attorney Docket No. 259/011

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Keum Joo LEE, et al.

Serial No. 09/955,126

Filed: September 19, 2001

For:

METHOD OF CLEANING DAMAGED

LAYERS AND POLYMER RESIDUE FROM SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents P.O. Box 1450 Alexandria, VA. 22313-1450

Sir:

It is respectfully requested that an extension of time for the period indicated below be granted in accordance with the provisions of 37 C.F.R. §1.136 to take the action required in the application identified in caption, as reflected by the papers submitted herewith.

X First Month

\$110 (\$ 55)*

Group Art Unit: 1746

Examiner: M. Kornakov

Confirmation No.: 8415

X_ Second Month

\$310 (\$155)*

X Third Month

\$530 (\$265)*

_Fourth Month

\$530 (\$265)*

_Fifth Month

\$530 (\$265)*

*(Small Entity) TOTAL FEE: \$950.00

The Commissioner is hereby authorized to charge the necessary extension fees to our Deposit Account No. 5-01645.

Respectfully submitted,

March 5, 2004

Date

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